

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S)

Byoung W. Min et al.

GROUP ART UNIT: 2823

APPLN. NO.:

10/002,054

EXAMINER: Hsien Ming Lee

FILED:

November 15, 2001

CONFIRMATION NO.

4428

TITLE:

SUBSTRATE CONTACT IN SOI AND METHOD THEREFOR

Certificate of Transmission under 37 C.F.R 1.8

Signature

Elaine Con

Printed Name of Person Signing Certificate

ISSUE OF PATENT TO ASSIGNEE PURSUANT TO 37 CFR 3.81

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Payment of the Issue Fee of this application is concurrently made with the request that the application issue in the name of Freescale Semiconductor, Inc. An assignment of all rights, title and interest in the instant application from Motorola, Inc. to Freescale Semiconductor, Inc. has been previously filed for recordation in accordance with 37 CFR 3.11, but it is not believed to have been recorded by the USPTO as of yet.

Respectfully submitted,

SEND CORRESPONDENCE TO:

Freescale Semiconductor, Inc. Customer Number: 23125

By:

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